

Notice of References Cited	Application/Control No. 09/920,296	Applicant(s)/Patent Under Reexamination SHIBATA ET AL.	
	Examiner Michael Van Handel	Art Unit 2617	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,982,411	11-1999	Eyer et al.	725/49
*	B	US-5,880,721	03-1999	Yen, Kerl	725/81
*	C	US-5,574,964	11-1996	Hamlin, Christopher L.	725/78
*	D	US-4,167,703	09-1979	Suwa et al.	455/143
*	E	US-6,118,976	09-2000	Arias et al.	725/118
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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